



# **I.FAST Period 2 Review, 15/07/2024**

**Oleg B. Malyshev (UKRI) / Claire Antoine (CEA)**

**WP9 coordinators**

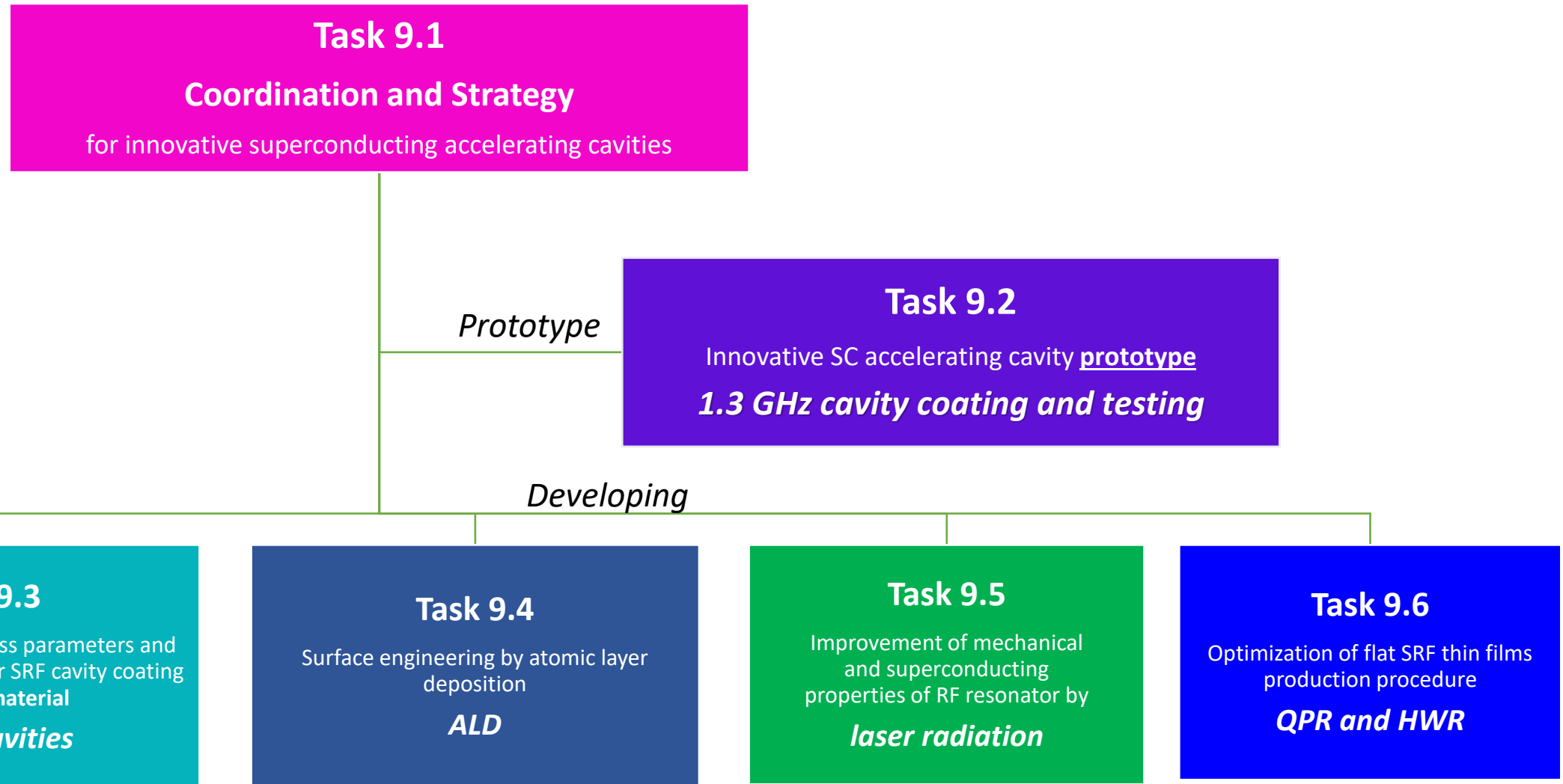
# WP9 objectives

- Define a strategy for innovative superconducting RF (SRF) cavities coated with a superconducting film.
  - Deposition techniques: PVD and ALD
  - Superconducting films: Nb, NbN, Nb<sub>3</sub>Sn, V<sub>3</sub>Si (and others) and SIS
  - Optimization of flat SRF thin films production procedure
- **Optimise and industrialise the production**
  - of seamless copper cavities and
  - of the deposition techniques.
- Produce and test prototypes of SRF (single-cell elliptical) cavities:
  - Initially with pre-prototypes with  $f = 6$  and 3 GHz
  - Scaling up for  $f = 1.3$  GHz.
- Test a new laser treatment of Nb coated cavity.

## ➤ Main goal:

- Improving the performance and reducing the cost of acceleration systems
  - both production and operation

# WP9 structure



# **Task 9.1:** Coordination and strategy for innovative superconducting accelerating cavities

*Task Leaders: C. Antoine (CEA), O. Malyshev (UKRI)*

- **Coordination:**
  - Regular WP9 meeting take place every 3-4 months
- **Strategy**
  - The representatives of **all HEI in Europe**, where TF SRF programme exist, are invited and present at the WP9 meetings
    - CERN and DESY/Hamburg Uni are not official partners in WP9
  - **Implementation of Accelerator Research and Development Roadmap of the European Strategy for Particle Physics (ESPP).** Annex 1, <https://cds.cern.ch/record/2800190?ln=it>
    - Claire and Oleg are also co-chairs for both: IFAST WP9 and EPSS theme on TF SRF
    - All WP9 members are involved in discussion and in providing necessary information for report to the Large Particle Physics Laboratory Directors Group (LDG) mandated by the CERN Council
  - **WP9 member were well involved in organising and participating in SRF-23 in USA**
  - **Organising the 11<sup>th</sup> International Workshop on Thin Films and New Ideas for Pushing the Limits of RF Superconductivity on 16-20 Sep. 2024**
    - Milestone MS37 on organising this workshop: **DELAYED** from M28 to M42
    - Deliverable D9.1 Thin film SRF roadmap report, **DELAYED** from M35 to M45.
      - Both D9.1 and MS37 delays are related to organising and discussing at the workshop, which dates have been moved from June 2023

## **Task 9.2:** Innovative SC accelerating cavity prototype

(*INFN-LNL, INFN-LASA, PICCOLI, UKRI, USI, CEA, IEE, HZB*) *Task Leader: C. Pira (INFN)*

**4 main steps to develop** to get the first 1.3 GHz Nb<sub>3</sub>Sn on Cu prototype produced and tested



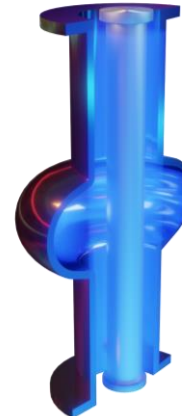
Cavity Forming

In progress



Surface Polishing

Standard process  
Ready



SC film coating

In progress



SC property evaluation  
RF test

Facilities Ready

Innovative Process in progress

## Task 9.2: Cavity Forming



### ❑ Production Protocol has been optimised

- ▶ CNC machine
- ▶ Reduced Annealing Temperature (400 °C, previous 500 °C)
- ▶ New intermediate Deep Drawing Step

### ❑ Several cavity substrates 1.3 GHz (and 6 GHz for task 9.3) sent to STFC and UniSiegen for coating tests

### ❑ New optimized die produced and tested by Piccoli

### ❑ OFE Copper procurement

### ▶ Ready for final prototype substrates production



*New 1.3 GHz Die for Spinning produced by Piccoli*

# Task 9.2: Cavity Polishing



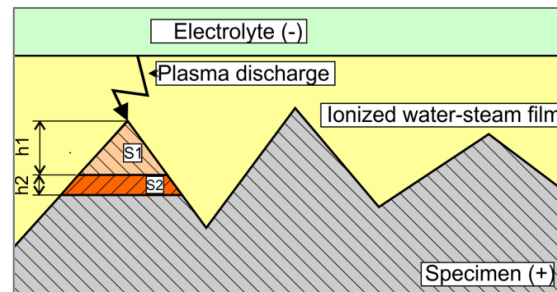
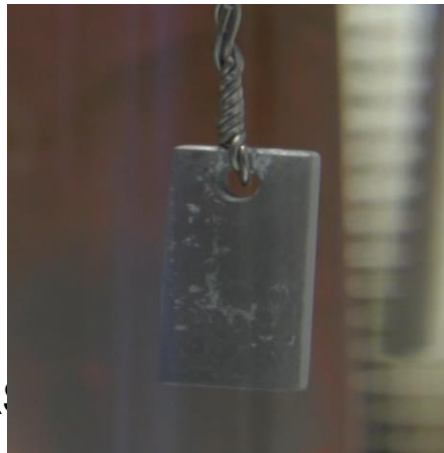
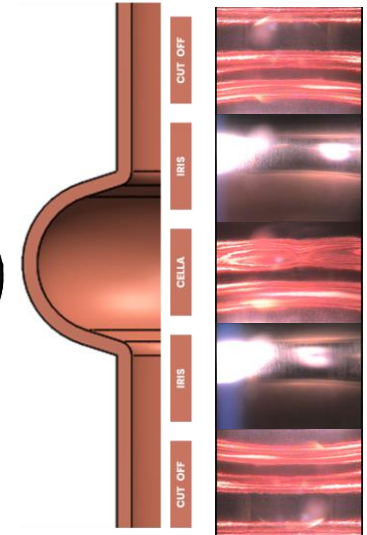
- ❑ Polishing via SUBU5 chemical process as baseline established @LNL
- ❑ Ongoing R&D on innovative Plasma Electrolytic Polishing (PEP)

## PEP Advantages



6 GHz Cu cavity

**No internal cathode**  
70  $\mu\text{m}$  removed in 10 minutes  
30 A (100  $\text{cm}^2 \rightarrow 1.3 \text{ GHz} \sim 300 \text{ A}$ )



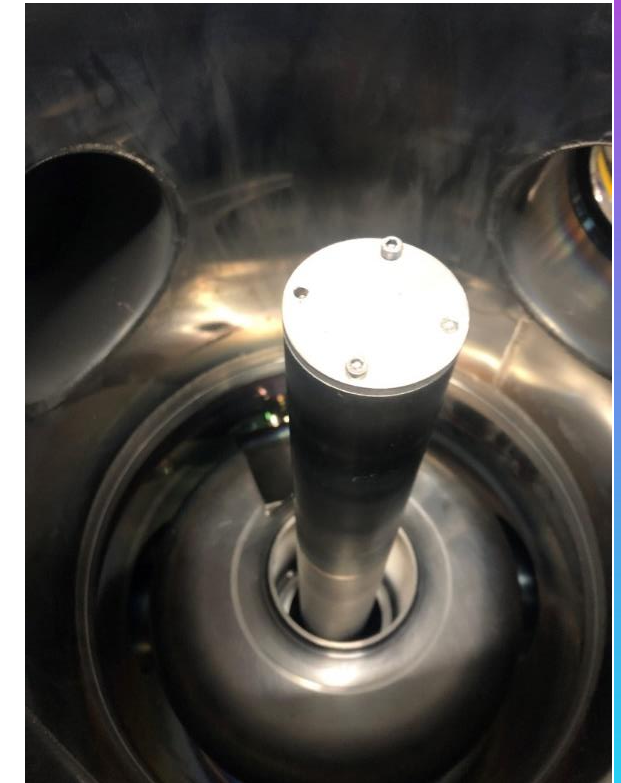
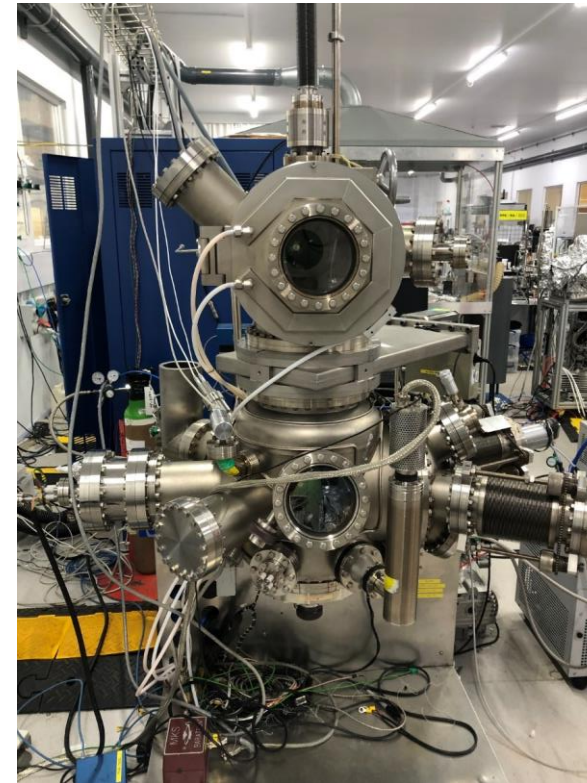
# Task 9.2: 1.3 GHz cavity Coating at INFN/LNL and UKRI/DL



Science and  
Technology  
Facilities Council



- 1.3 GHz Coating systems is ready
- First tests on cavity mockup in 2024
- R&D on samples successfully ongoing  
→  $T_c$  close to  $Nb_3Sn$  nominal one (best results on Cu so far in literature)



*PVD (left) and Dipping (right) coating systems @LNL*

*PVD coating system @UKRI/DL outside (left) and inside with a cavity (right)*

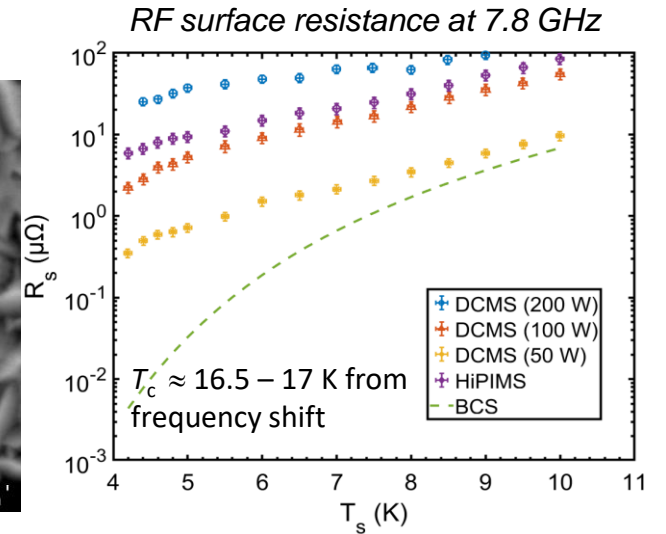


# Task 9.3: Optimisation of process parameters and target development for SRF cavity coating with A15 material

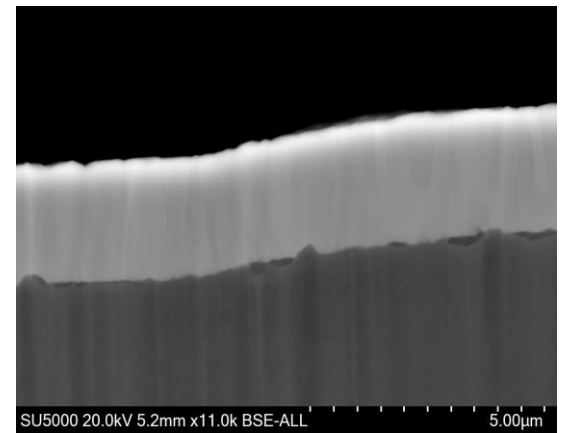
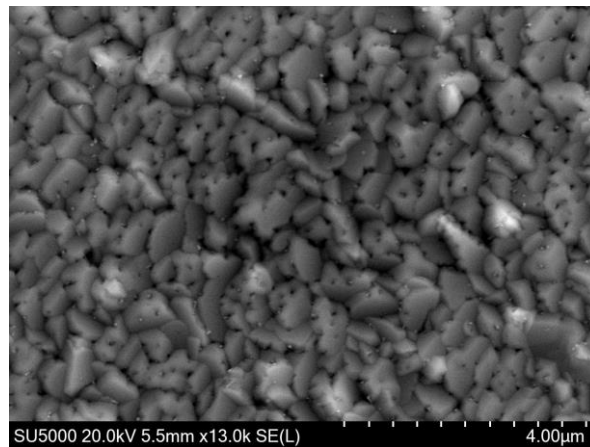
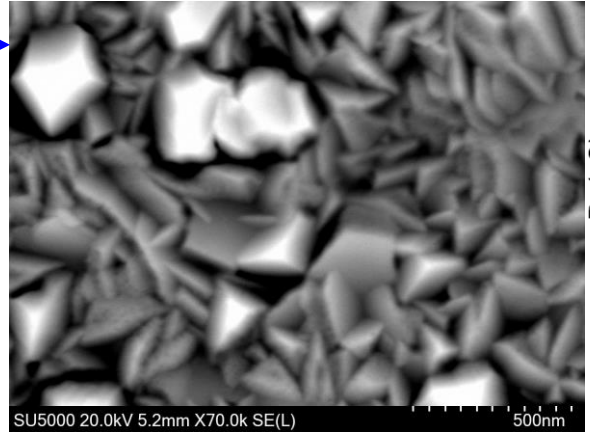
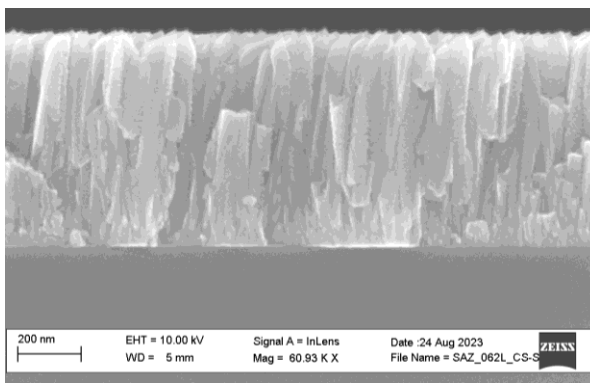
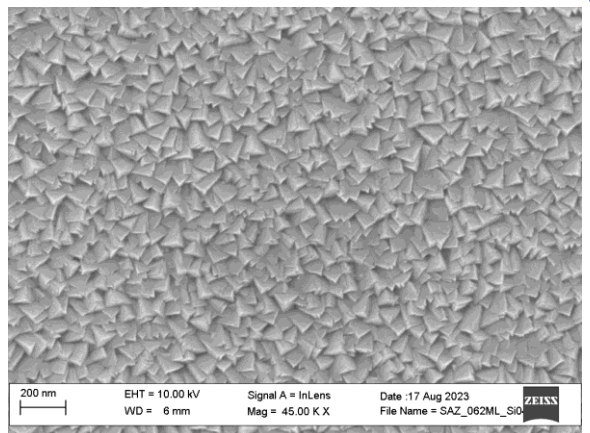
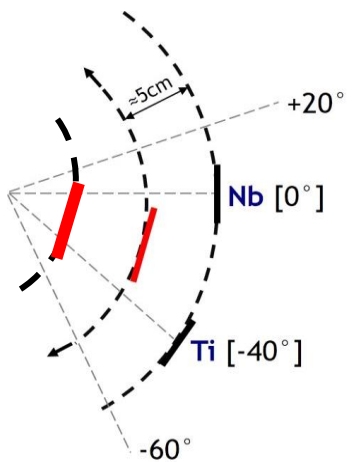
(UKRI, INFN, IEE, USI, HZB, HZDR) Task Leader: R. Valizadeh (UKRI)

## Development of thin films on planar copper substrates:

- ❖ Nb<sub>3</sub>Sn at INN/LNL
- ❖ Nb<sub>3</sub>Sn, NbTi and V<sub>3</sub>Si at UKRI
- ❖ NbN at US

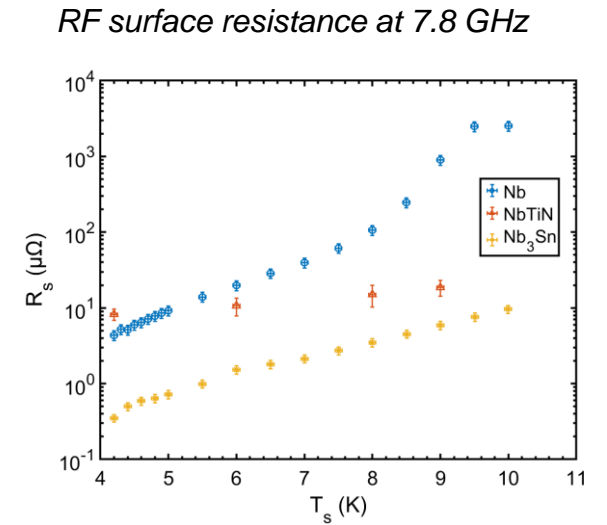
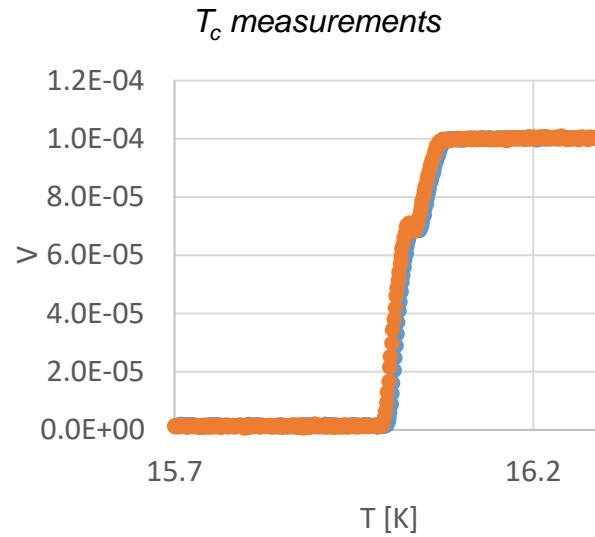


Increase sub.-target distance  $\mathcal{L}$



# **Task 9.3:** Optimisation of process parameters and target development for SRF cavity coating with A15 material (UKRI, INFN, IEE, USI, HZB, HZDR) Task Leader: R. Valizadeh (UKRI)

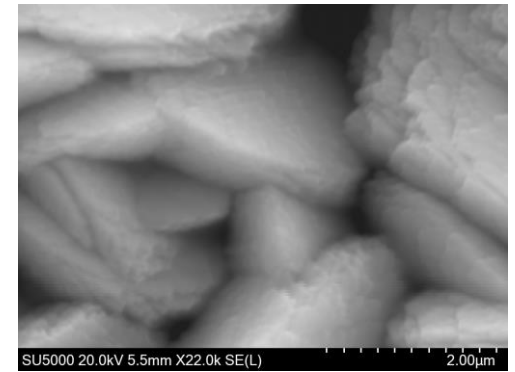
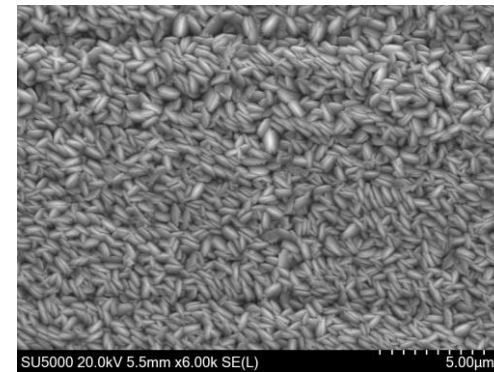
Depositing NbTiN thin films from Nb rod and Ti wire on a 6 GHz RF cavity at UKRI



After several iteration of changing Ti wire loops composition of  $Ti_{0.5}Nb_{0.5}$  reached

➤ **Deliverable D9.3:** First 6 GHz cavity coated and characterised - DELAYED from M36 to M42.

The Deliverable was delayed in order to achieve more successful results. The cavity deposited with NbTiN was produced,  $T_c$  was correct, however the Q-value was 2 decades lower than what it was expected due to film delamination. A new cavity is already prepared but not tested yet.

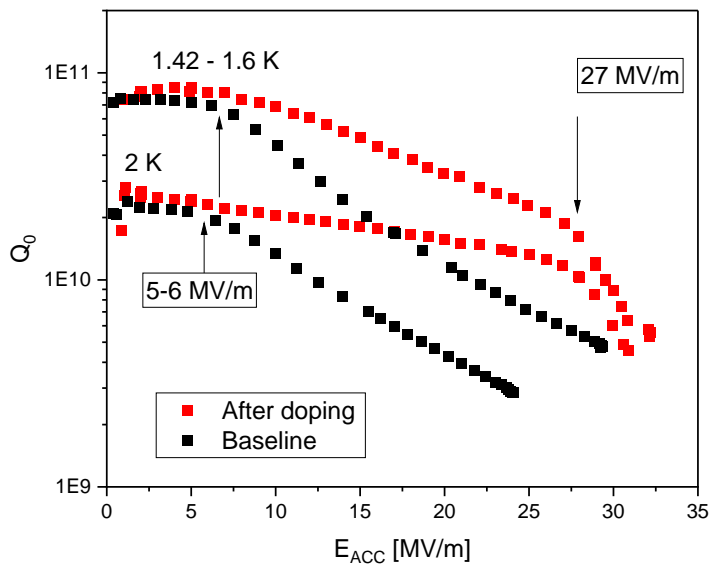


# Task 9.4: Surface engineering by atomic layer deposition (ALD)

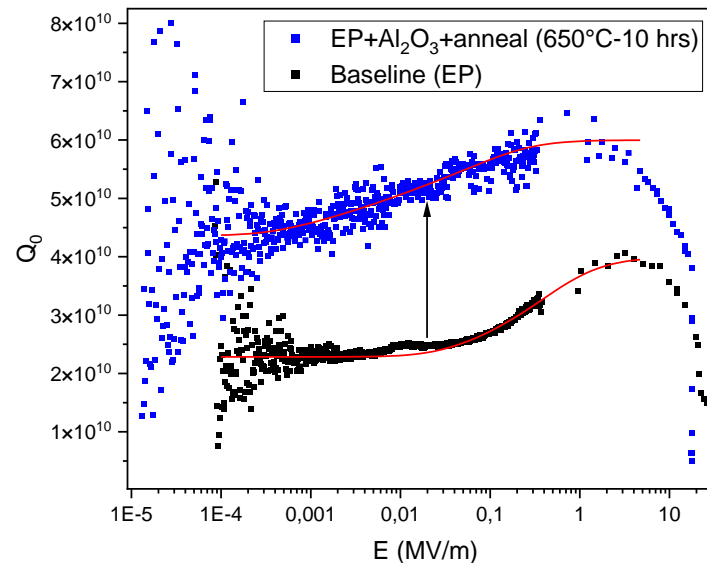
(CEA, CNRS) Task Leader: T. Proslie (CEA)

- ✓ **Increased Q at low field** for 3D superconducting resonators 1,3 GHz. Publication + patent
- ✓ **Increased penetration field** on samples by 24%. First depositions of multilayers in 1.3 GHz cavities
- ✓ **N doped cavity by ALD of NbN**. Optimization underway.  
First depositions of multilayers in 1.3 GHz cavities

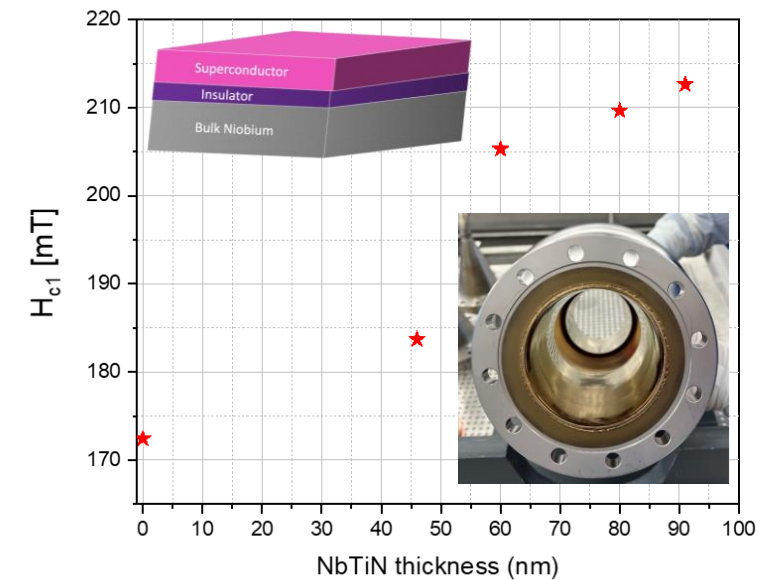
Doping by ALD: NbN (5nm) + thermal annealing



High Q studies for Qubits and accelerators



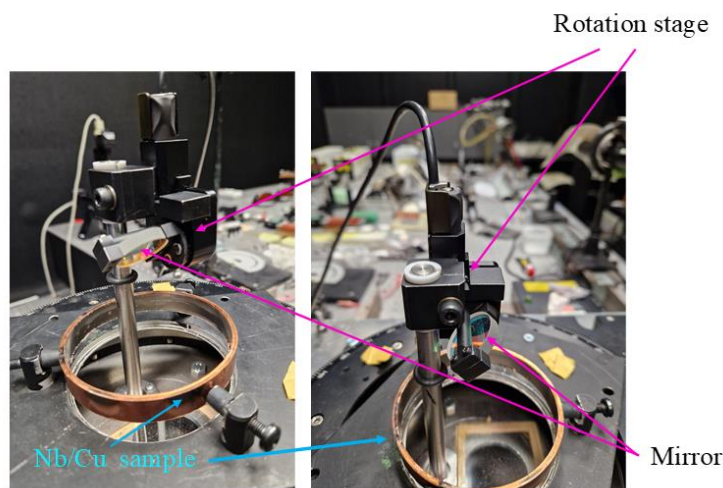
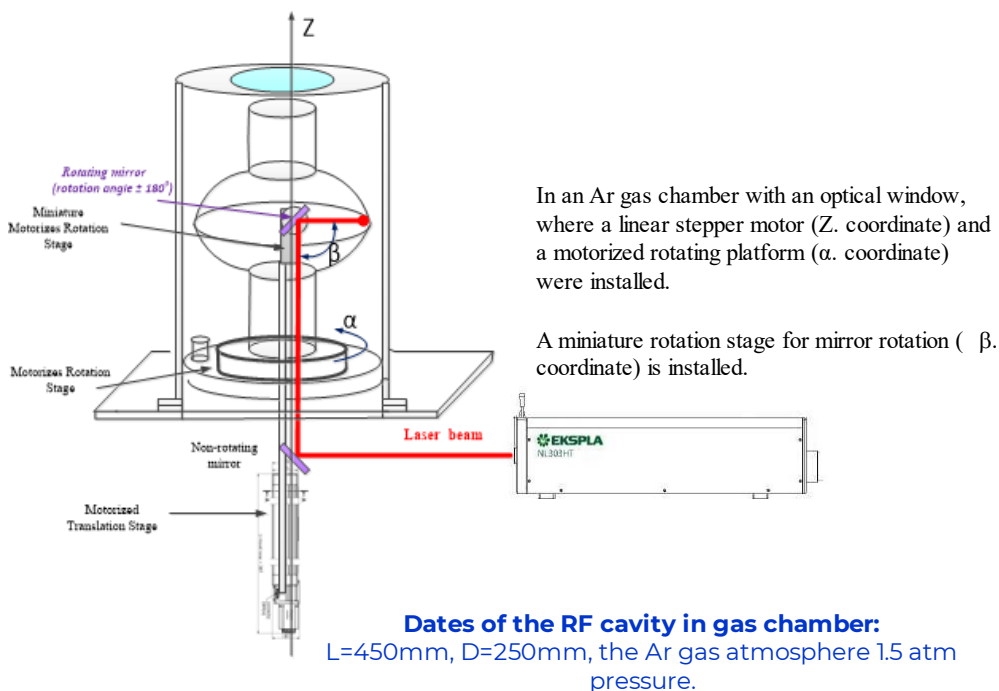
High Gradient for accelerators increased penetration field.



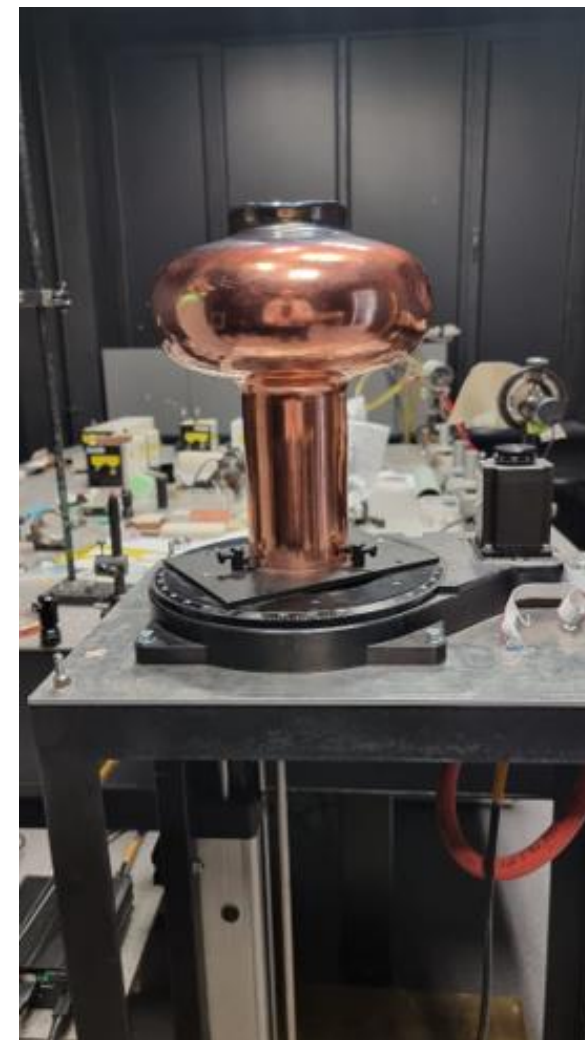
# Task 9.5: Improvement of mechanical and superconducting properties of RF resonator by laser radiation

(RTU, UKRI, INFN, IEE, HZB) Task Leader: A. Medvids (RTU)

## Improvement of mechanical properties of Nb/Cu structure after irradiation by nanosecond laser



A miniature rotation stage for mirror rotation ( $\beta$  coordinate) is installed.

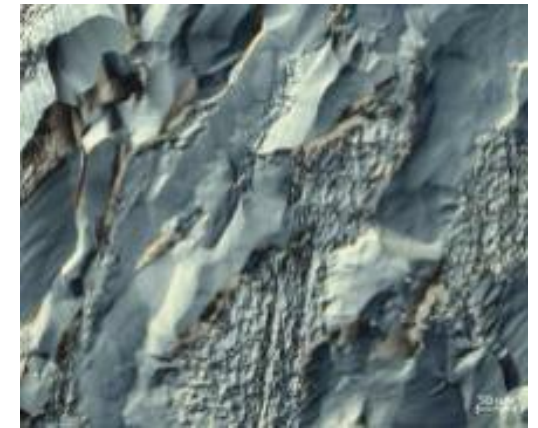
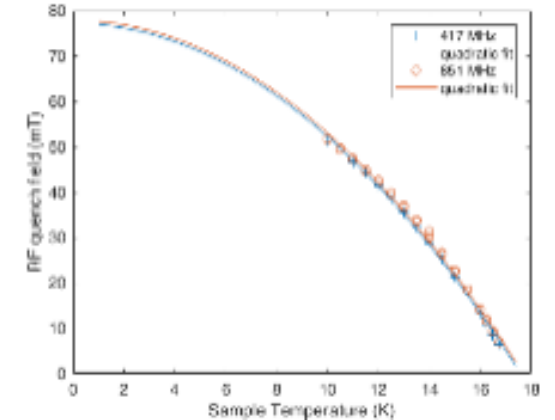


➤ **Milestone MS41:** A facility for laser operation for complex 3D treatment is tested on 1.3 GHz cavity (Month 36)  
**A 2-month DELAY** because of technical problems.

## Task 9.6: Optimization of flat SRF thin films production procedure

(HZB, INFN, UKRI, USI, CEA) *Task Leader: O. Kugeler (HZB)*

- HZB has experienced a cyber attack in summer 2023
  - which led to the encryption of most programming code including virtualised backups for the QPR operation
  - The attack also affected cryogenics, radiation protection, RF operation and utilities.
  - No QPR measurements have been performed for 7 months.
- QPR samples from UKRI-DL (multilayer), CEA (ALD coating) and INFN-LNL (Nb<sub>3</sub>Sn) were deposited and waiting for RF testing:
  - The INFN-LNL (Nb<sub>3</sub>Sn) sample has been tested for quench field
  - Others will be measured in 2024.



## Summary

✓ **On track with Deliverables and Milestones**  
*(minor delays due to technical challenges)*

# What is a difference between ARIES, IFAST and iSAS?

- ARIES**
- ▶ Substrate preparation
  - ▶ Nb thin film
  - ▶ Planar samples only

▶  $Nb_3Sn$ , NbN, NbTiN,  $V_3Si$  thin film

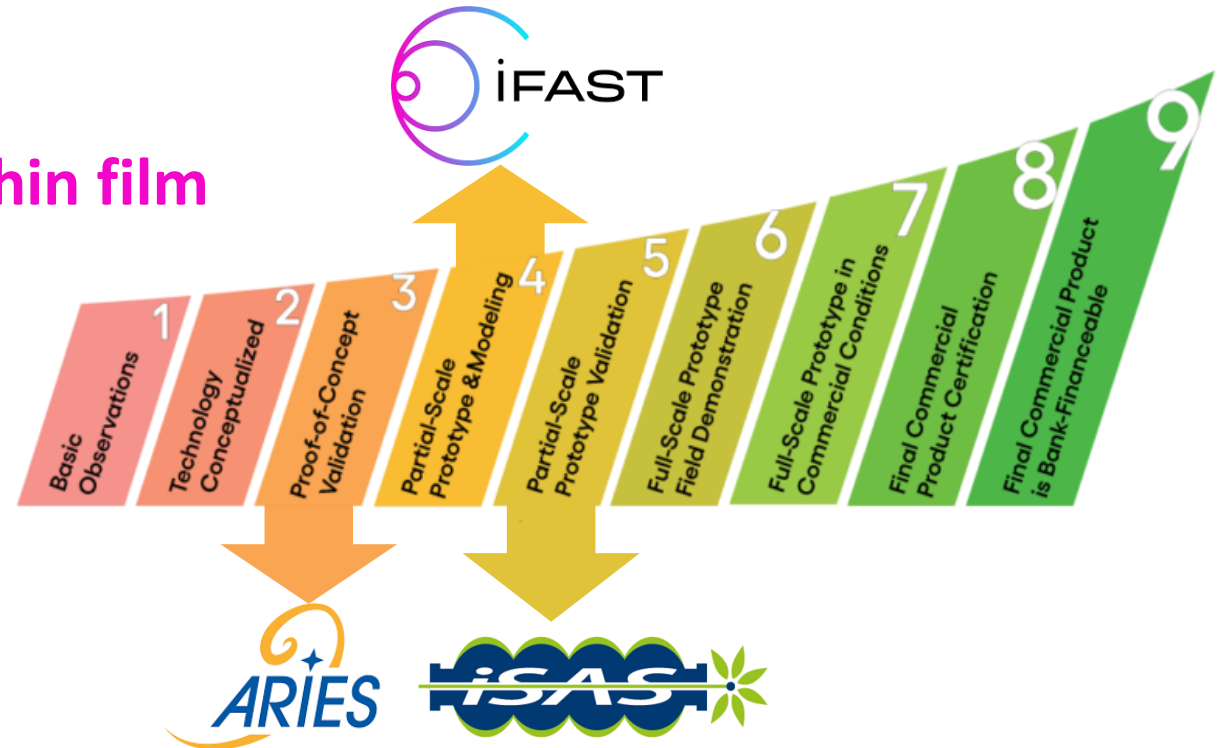
▶ Interface diffusion

▶ Target Production

▶ Coating Parameters

▶ Depositing on and

testing 1.3 GHz cavity



- iSAS**
- ▶ Trapped Flux
  - ▶ Tuning





# **I.FAST Period 2 Review, 15/07/2024**

**Partners: UKRI, DESY, DLS, Soleil.**

**O. Malyshev (UKRI) - Task Leader**



# (1) NEG coating pumping properties evaluation

## ➤ Testing facilities:

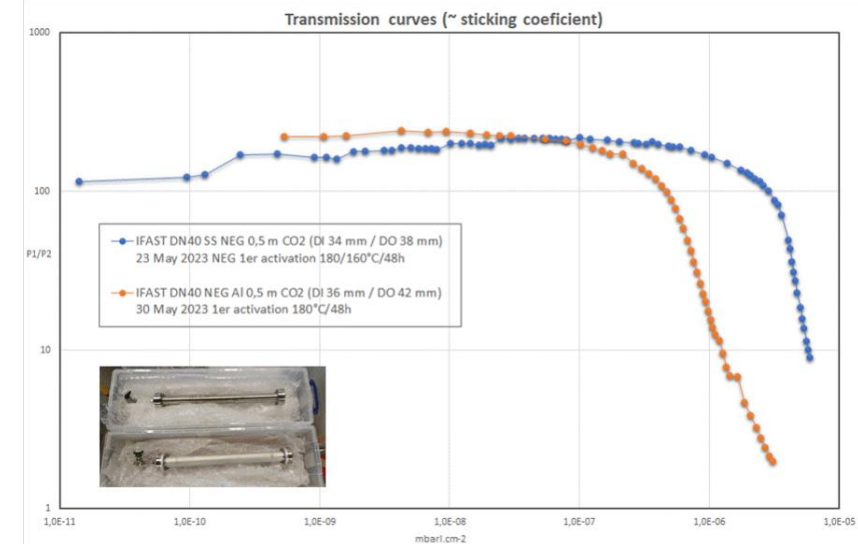
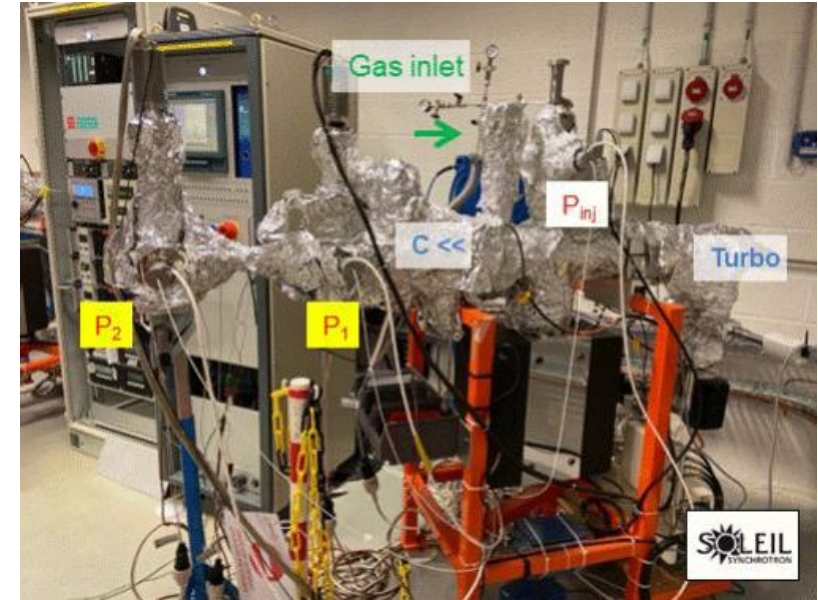
- Four facilities have been designed on similar principles and can be used with similar samples.
- Thus, measurements can be cross-verified in 4 laboratories.

## ➤ Samples:

- ID = 34-36 mm and L = 500 mm and equipped with two CF40 flanges
- made of 316 LN and aluminium
- NEG coated at UKRI,
- then tested at DLS, DESY, Soleil and UKRI.

## ➤ Samples:

- ID = 20 mm and L = 500 mm and equipped with two CF40 flanges
- made of copper
- Prepared at DESY
- NEG coated at UKRI,
- then tested at DLS, DESY, Soleil and UKRI.



## (2) PSD from NEG coated accelerator vacuum chambers

➤ This activity is the main objective for Task 10.5

### Sample preparation:

#### ➤ Problems in P2:

- 1) Low quality of deposition targets (at UKRI) results in coating with low performance
  - Solution: changing a supplier
- 2) Non-uniform deposition (at UKRI and DESY) on tubes with ID = 20 mm and L = 1 m
  - 10 cm from the edges were not fully coated
    - Solution: longer coil or short moving coil
    - Working with instrumentation:
      - Deposition power supply,
      - Discharge gas pressure,
      - Target alignments

✓ Sorted out

## (2) PSD from NEG coated accelerator vacuum chambers (c-ed)

- Main progress:
  - Two PSD samples deposited at UKRI with a TiZrV columnar film in Nov-Dec 2023
    - Samples have been tested at UKRI for pumping properties after activation to 180 °C for 24 h
    - Then shipped to DLS and Soleil for PSD measurements
  - PSD facilities:
    - Access limited by technical shutdowns
    - ✓ Samples have been installed at DLS in March 2024 and Soleil in April 2024.
    - ✓ PSD experiments are ongoing



*The TiZrV NEG coated copper sample with ID = 20 mm and L = 1.0 m installed in the SR beamline at DLS*

- Deliverable Report “First PSD data from NEG coating”:
  - Due Date – Month 36 from installation date
    - Too sort from the date of installing on SR beamlines
  - Extension for 8 months is required to collect data and analyse the results
  - New deadline – **Month 44**